Masahiro Miyauchi

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Educational background

1989- 1993	Bachelor of Materials Science, Tokyo Institute of Technology (March, 1993)
1993- 1995	Master of Materials Science, Tokyo Institute of Technology (March, 1995)
1999- 2002	Doctor of Philosophy (Ph. D.), Research Center for Advanced Science and
	Technology (RCAST), University of Tokyo (September, 2002)

Professional career

1995-2006	Research Scientist, TOTO Ltd.
<2002-2003>	Temporary Position: Visiting Lecturer, Materials & Structures Laboratory,
	Tokyo Institute of Technology.
2006-2011	Senior Research Scientist, National Institute of Advanced Industrial Science and
	Technology (AIST)
<2009- 2011>	Temporary Position: Visiting Associate Professor, Research Center for
	Advanced Science and Technology (RCAST), University of Tokyo.
2011- present	Associate Professor, Tokyo Institute of Technology

Research fields

photo-electrochemistry, photocatalysis, solar cell, wet chemical synthesis of nanoparitcles, quantum dot

List of publication (papers and patents)

http://www.eim.ceram.titech.ac.jp/miyauchiPub.html (Laboratory's website) http://scholar.google.co.jp/citations?hl=en&user=f8vRP-QAAAAJ (Google Scholar)